Technical specifications for 2D material transfer system

I.Bidder Eigiblity Criteria

| Bidder Eigiblity | Complied/Not | Ref.Pg No |
|--------------------------------------------------------------------------------|--------------|-----------|
| | Complied | |
| 1.The bidder/OEM should have supplied at least 2 similar items to IITs, NITs, | | |
| IISERs, CSIR Labs or other Govt. organizations in the last 3 years, PO copies | | |
| or installation certificates along with contact details of end user need to be | | |
| submitted as the proof of supply. IIT Madras reserves its right to verify the | | |
| claims submitted by the bidder and the feedback from the previous customers | | |
| will be part of technical evaluation. | | |
| 2. The service center should be within India, Proof of facility registration, | | |
| location & contact details to be provided along with technical bid. | | |

II.Technical specifications

| Specifications | Complied/Not Complied | Ref.Pg No |
|--------------------------------------------------------------------------------|-----------------------|-----------|
| The dry transfer / aligner system will be used to prepare van der Waals | | |
| heterostructures of 2D materials | | |
| Sample Stage | | |
| XYZ-Theta stage, with Coarse adjustment of 360 degrees, Fine adjustment of | | |
| +/- 5 degrees or better, High precision micrometer movements of 5 micron or | | |
| better, XY travel range of 10 mm or more, Z travel range of 5 mm (or more). | | |
| digital micrometer on one of the XY axis with 1 micron resolution. | | |
| Stamping Stage | | |
| XYZ stage, with XYZ travel of 10 mm or more, High precision micrometer | | |
| movements of 5 micron (or better) in XY direction and 10 micron (or better) in | | |
| Z-direction, Black anodized aluminium or black anodized aluminium alloy | | |
| construction and with glass slide holder, digital micrometer on one of the | | |
| complementary XY axis with 1 micron resolution, tilting platform. | | |
| Sample Stage Heater with temperature controller | | |
| From RT to 200 °C (or more), PID controlled, Uniform temperature control | | |
| over the sample with 1-degree C resolution (or better). | | |
| Vacuum provision for holding samples | | |
| Vacuum Chuck to hold samples of 10 mm x 10 mm size (or more), Vacuum | | |
| pump. Temperature-compatible material of construction | | |
| Microscope | | |
| Co-axial or Epi-illumination from the top, Variable Intensity White LED, Long- | | |
| working distance Apochromatic objective, Maximum total optical | | |
| magnification of at least 25X | | |
| Zoom Ratio of 8 times (or more) | | |
| Camera | | |
| C-mount digital color camera, 5 MP (or better), HDMI or USB output | | |
| compatible, Large optical size sensor sizes of 1/2.5" (or better), BMP/PNG/JPG | | |
| images | | |
| Base Plate | | |
| Magnetic SS M6 tapped hole grid with level adjustment for firmly mounting all | | |
| the components | | |
| 1-year Warranty | | |
| On-site installation and training | | |